

Research Activities in ECOPICS

Mingyi Dong

dongmy@ihep.ac.cn

Institute of High Energy Physics, CAS

State Key laboratory of Nuclear detection and electronics

on behalf of the ECOPICS project (IPHC, IHEP, SDU, CCNU)



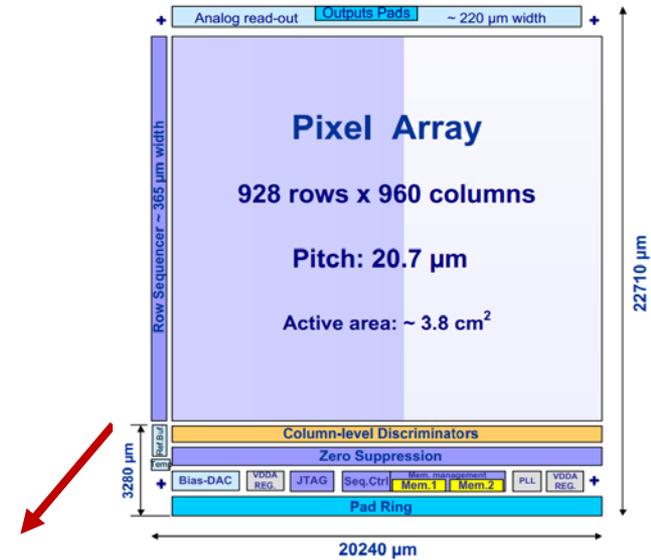
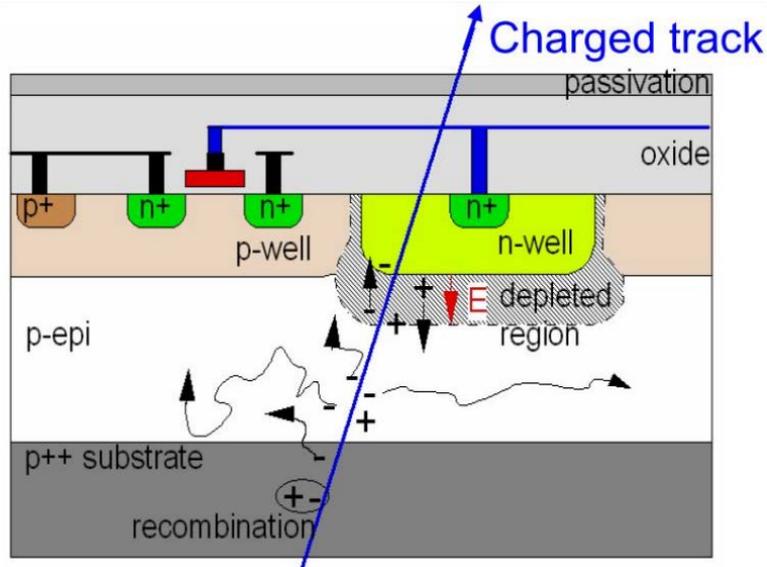
Outline

- Part of research activities in ECOPICS (Electron collider oriented pixelated CMOS sensor development)
- A CMOS pixel sensor (CPS) detector prototype study
- CMOS pixel sensor design and planned MPW run with IPHC

Outline

- Part of research activities in ECOPICS (Electron collider oriented pixelated CMOS sensor development)
- **A CMOS pixel sensor (CPS) detector prototype study**
- CMOS pixel sensor design and planned MPW run with IPHC

CPS and prototype for BESIII MDC Upgrade

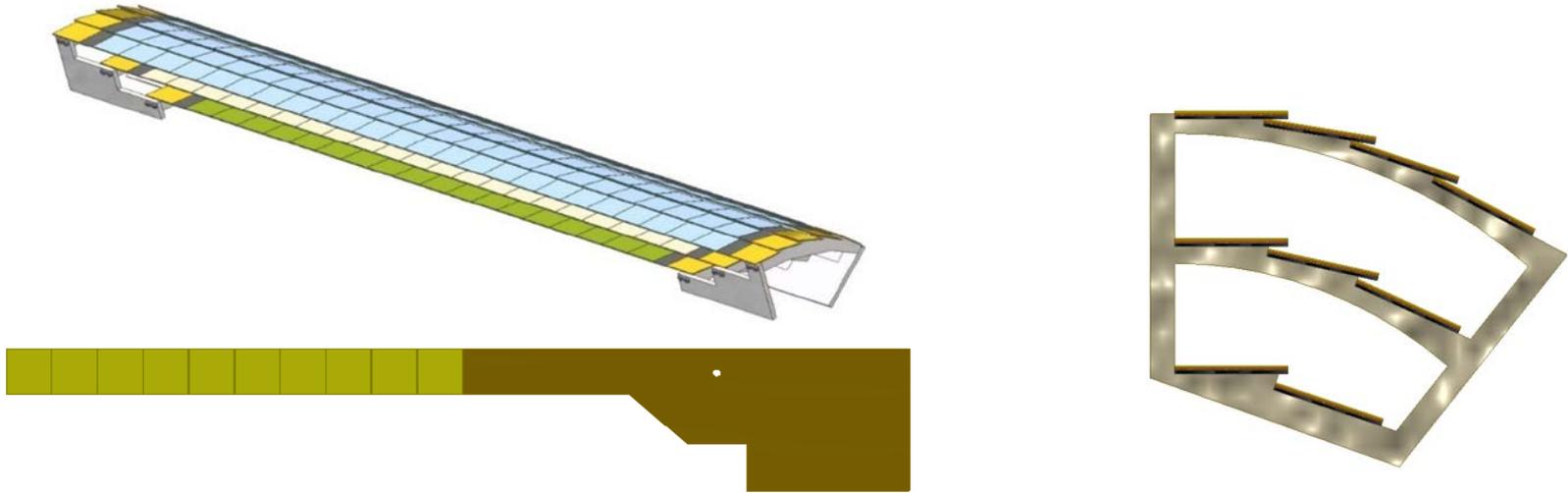


- CMOS pixel sensors have attractive features: low material budget, low power consumption, high spatial resolution and low cost
- Initiated by IPHC in Strasbourg
- Used for the STAR pixel detector, the ALICE ITS upgrade and the CBM MVD.
- Also for ILC, CEPC, R&D

A MIMOSA28 sensor designed for the STAR PXL detector is selected as one of the prototype schemes for the inner MDC upgrade

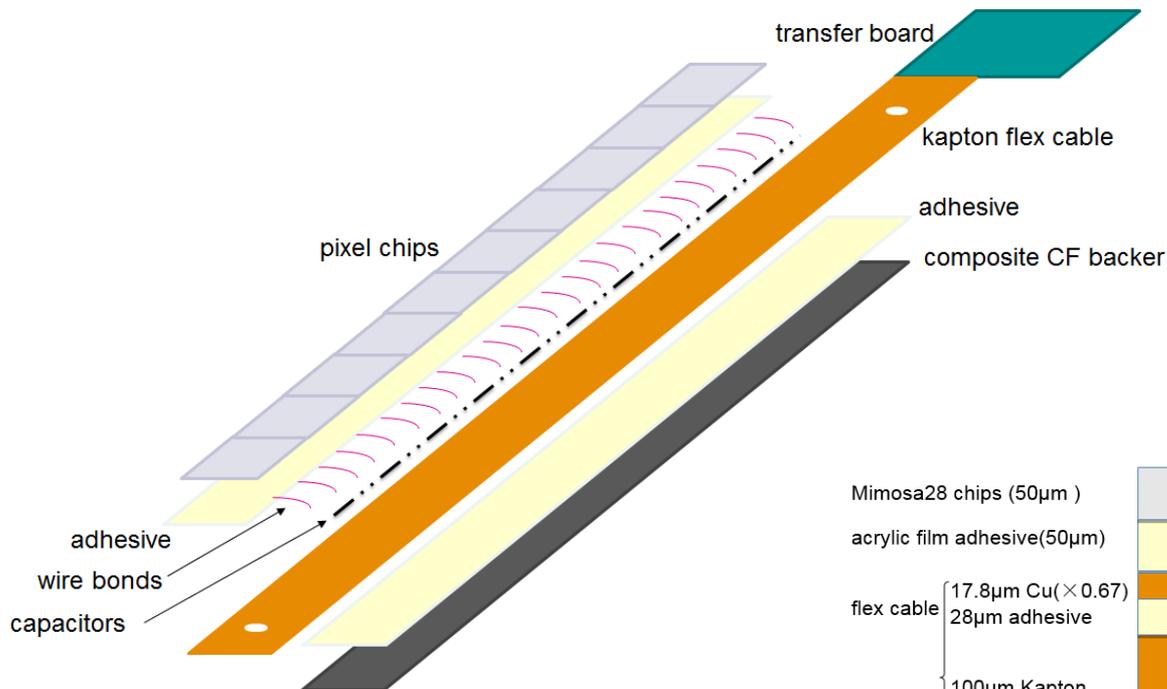
- Density: 20.7 μm pixel pitch, ~0.9Mpixels/chip
- Spatial resolution: ~3.5 μm
- Rating capability: ~10⁶Hz/cm²
- Material budget: ~50 μm thick
- Radiation tolerance: ~1 MRad, 10¹³ n_{eq}/cm²
- Room temperature operation

R&D target: a CPS Prototype



- A CPS detector prototype
 - 1/10 Coverage of the inner tracker ($\sim 720\text{cm}^2 \rightarrow 180$ chips $\rightarrow 180\text{M}$ pixels)
 - ϕ direction: 2, 3 and 4 ladders for the 1st, 2nd and 3rd layer respectively
 - Z direction: 2 sets of ladders each layer
 - 10 Mimosas28 chips with dimension of $2\text{cm} \times 2\text{cm}$ in each ladder

Ladder Design



Mimosa28 chips (50 μ m)

acrylic film adhesive(50 μ m)

flex cable { 17.8 μ m Cu(\times 0.67)
28 μ m adhesive

100 μ m Kapton

28 μ m adhesive
17.8 μ m Cu(\times 0.23)

acrylic film adhesive(50 μ m)

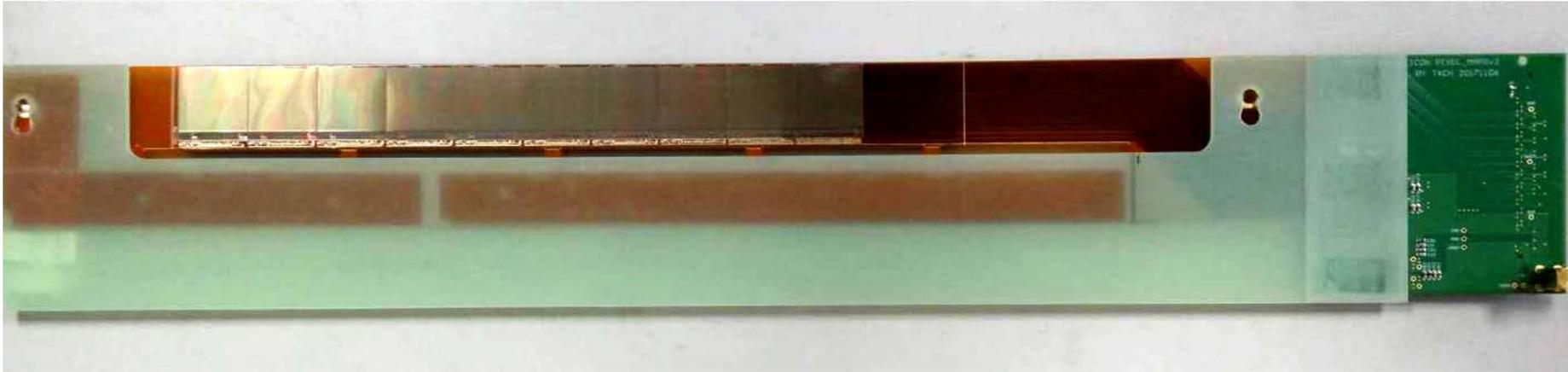
sandwich support structure:

carbon fiber plate and
PMI foam (equivalent
thickness: 350 μ m CF)

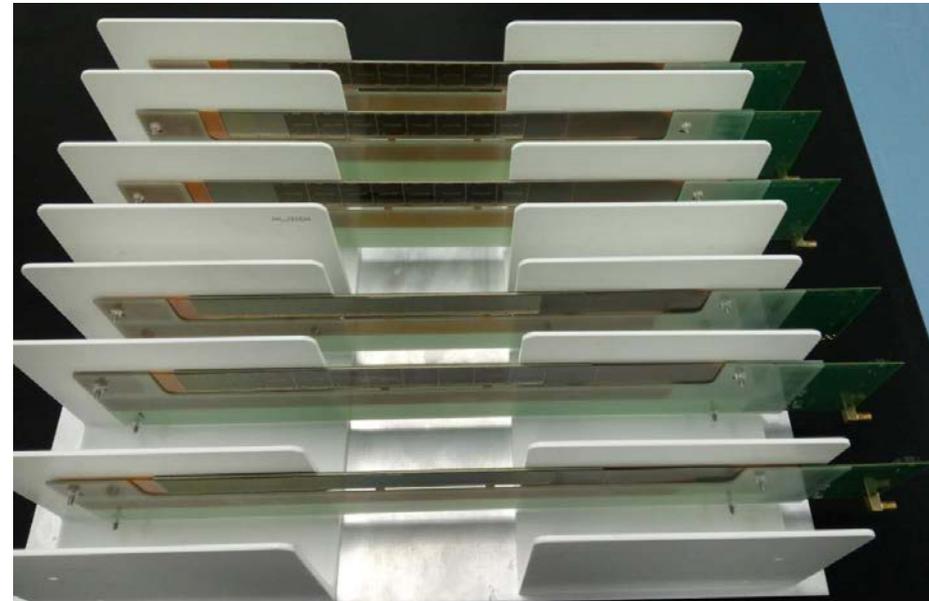


- Ladder: basic building and functional block of the detector, key issue for the prototype
 - 10 Mimosa28 chips (50 μ m)
 - Flex cable
 - Carbon fiber mechanical support

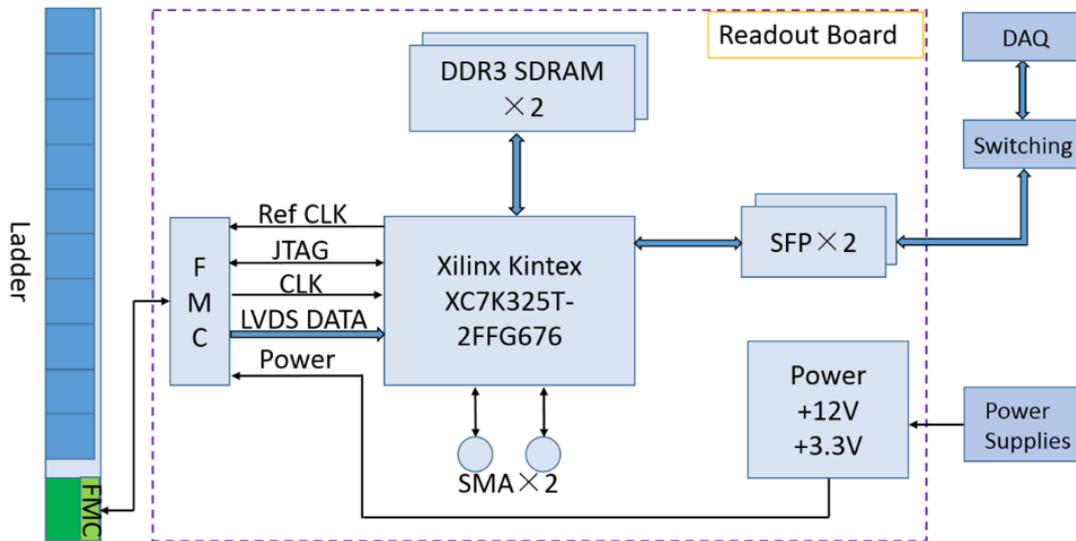
Ladder Assembly



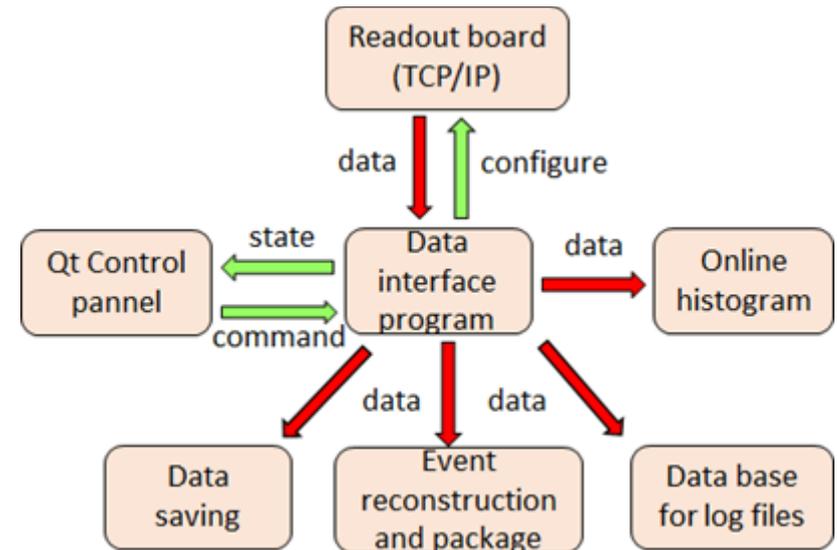
- Ladder assembly was operated at a dedicated jigs to ensure the location accuracy of the chips
- Material budget of the ladder by calculation: $0.37\% X_0$ /ladder
- Chip location accuracy measured by imaging machine: $< 10\mu\text{m}$



Readout Electronics and DAQ



- Distributed system
- Ladder → FCB → Readout Board → Switching → PC
- SiTCP : high-speed and highly reliable data transmission
- Readout speed: 30~40MB/s/ladder

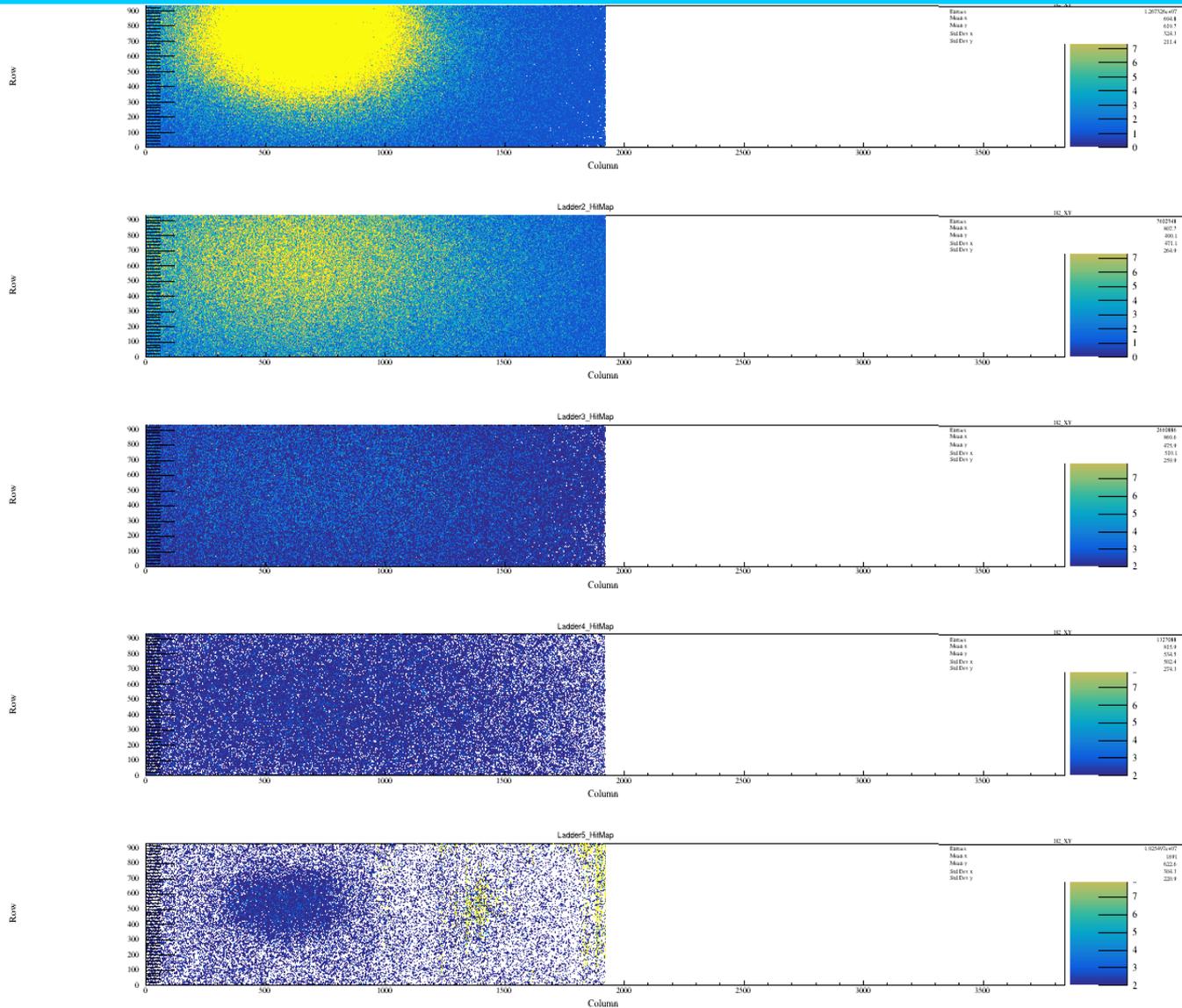


Test in IPHC



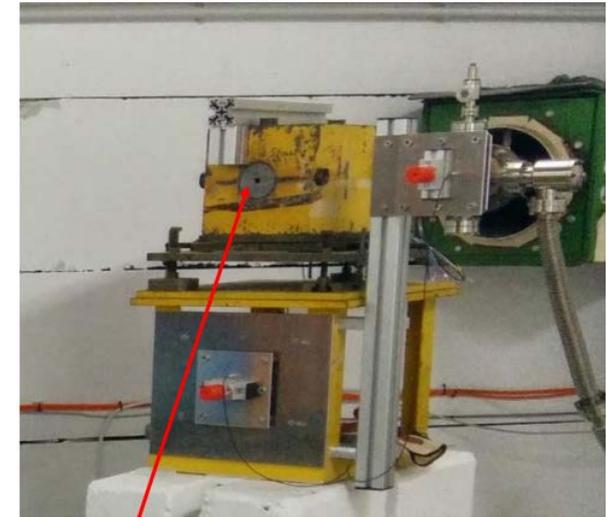
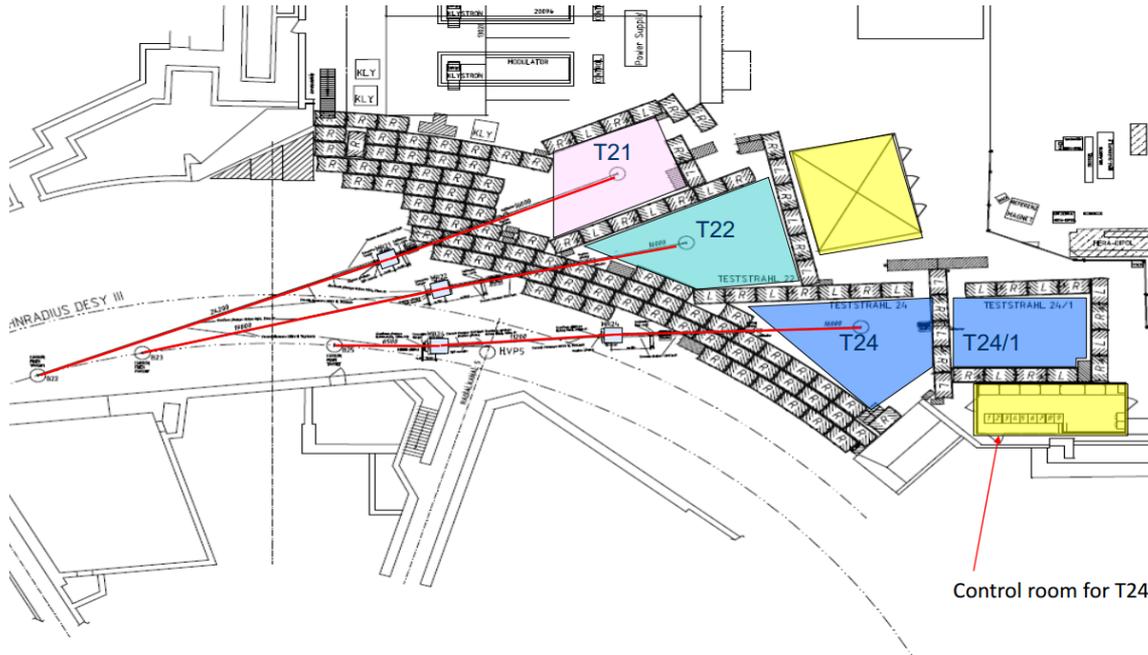
- Test system was shipped to IPHC in October, 2018
- We did noise test, threshold scan, radioactive source test, stability test, ... to make sure the system works well in beam
- We also discussed and determined the beam test plan in DESY

Test in IPHC



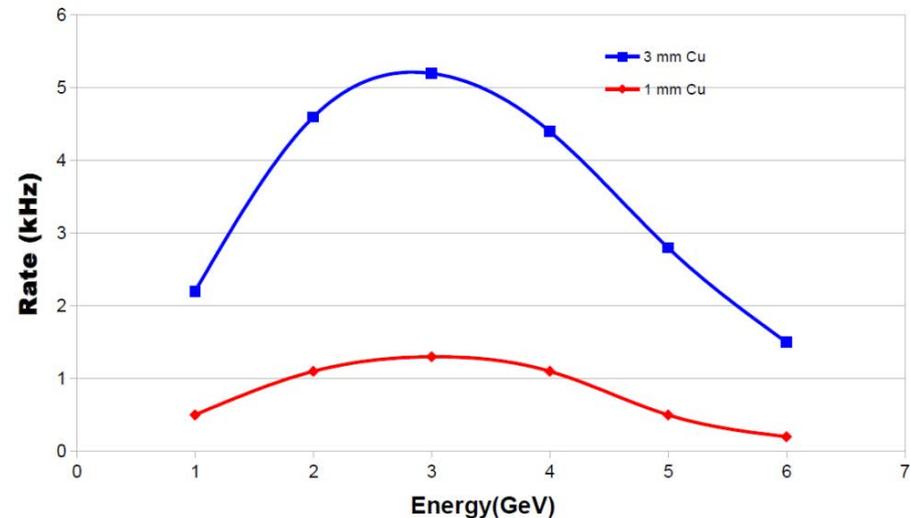
- Test with Sr-90 source. Chips response by using a collimator

Beam Test in DESY



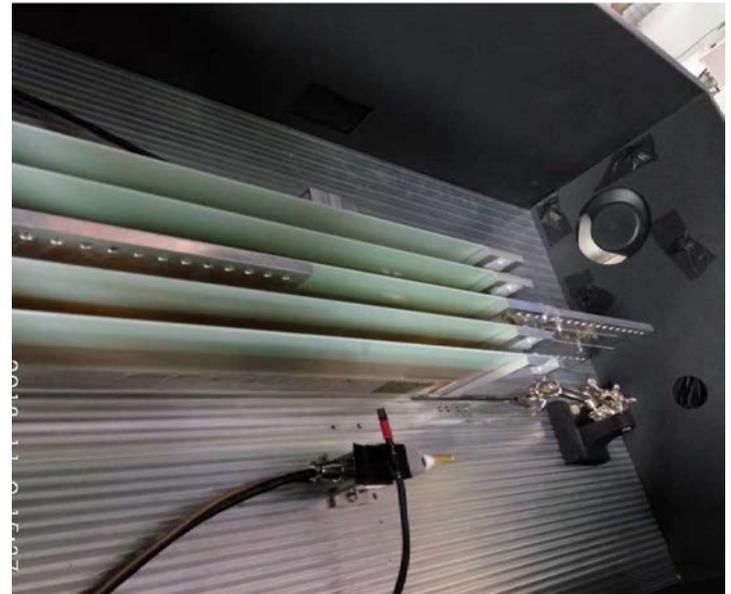
lead collimator

- T24 testbeam
- PICSEL group from IPHC, Strasbourg and Chinese group from IHEP
- November 5-11, 2018

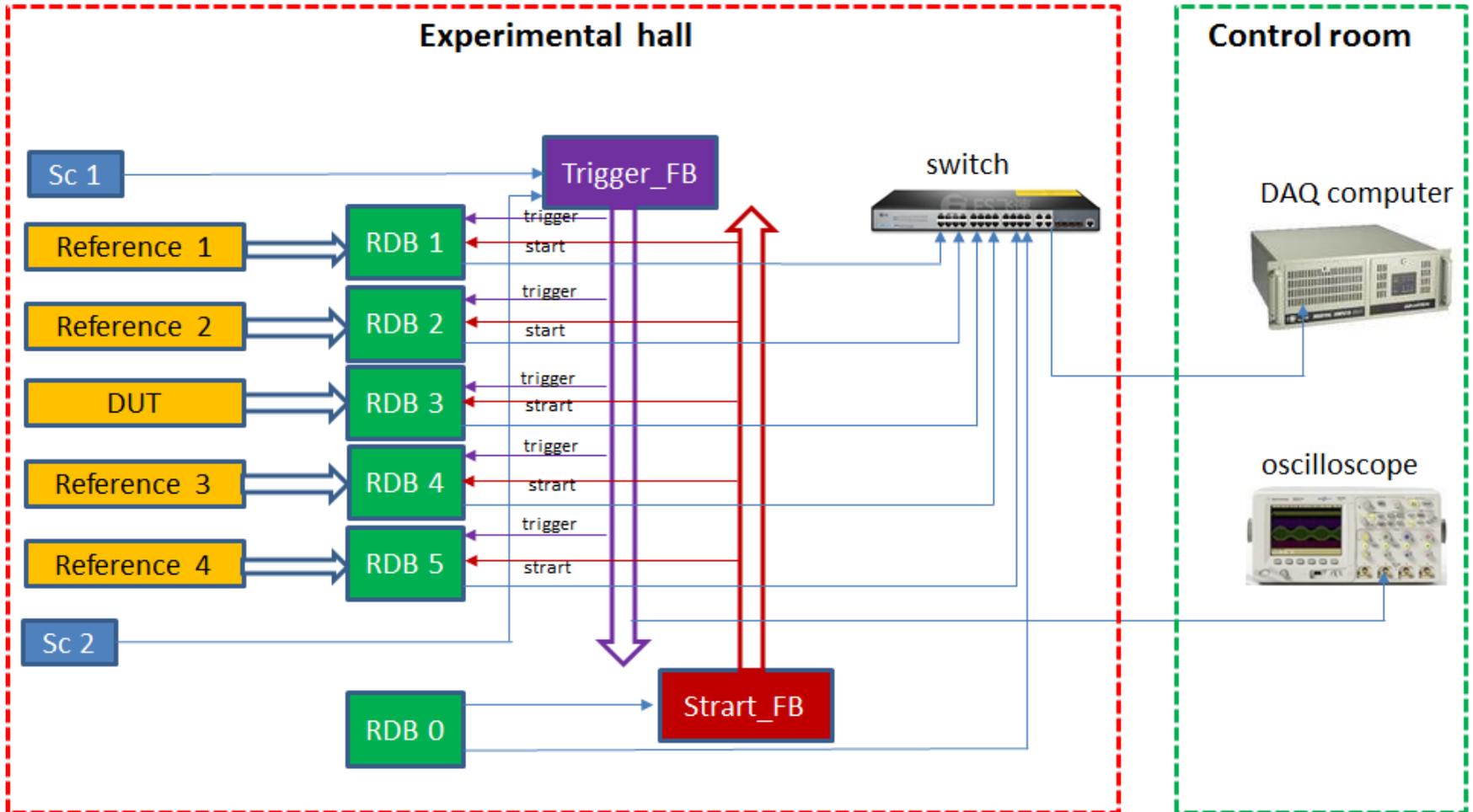


Beam Test in DESY

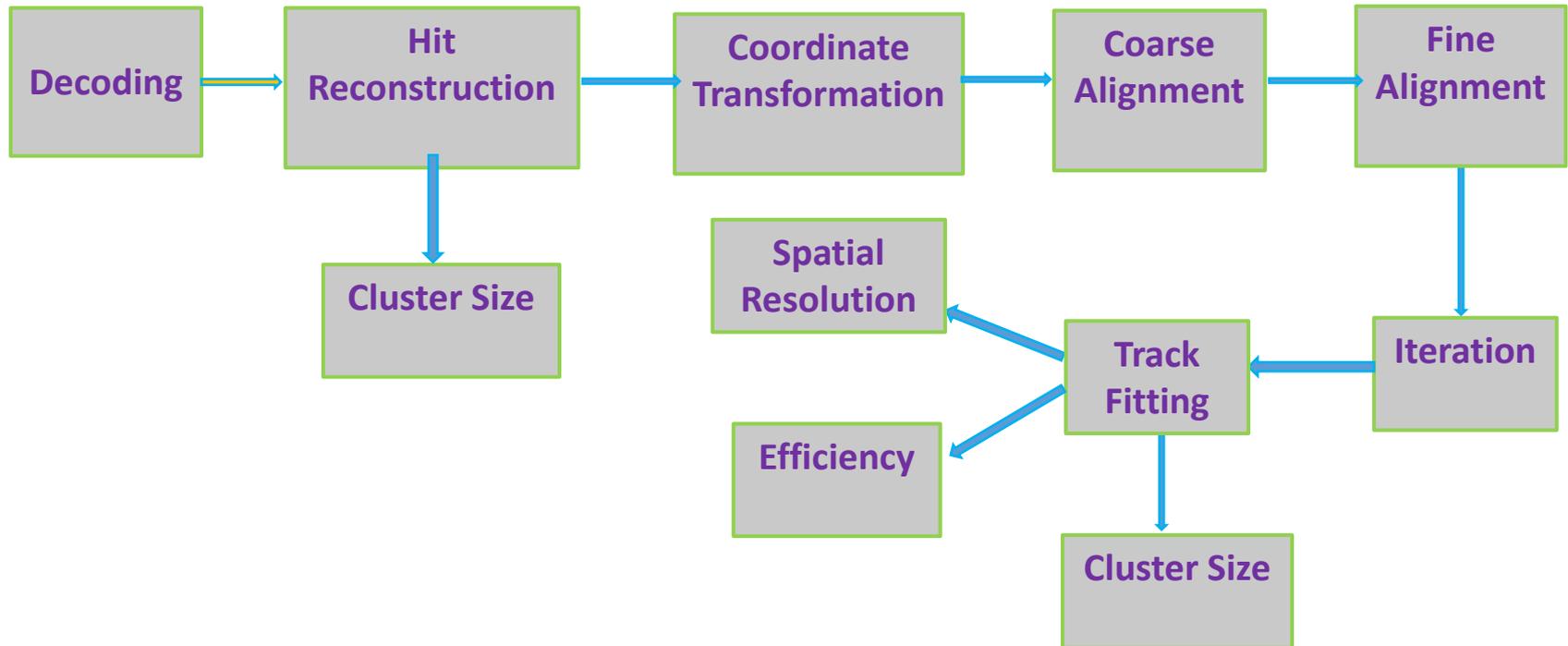
- Energy Scan
- Ladder scan
- Threshold scan
- Gap between the neighboring chips
- Material budget test
- Target scattering test
- Cooling air flow



System Setup

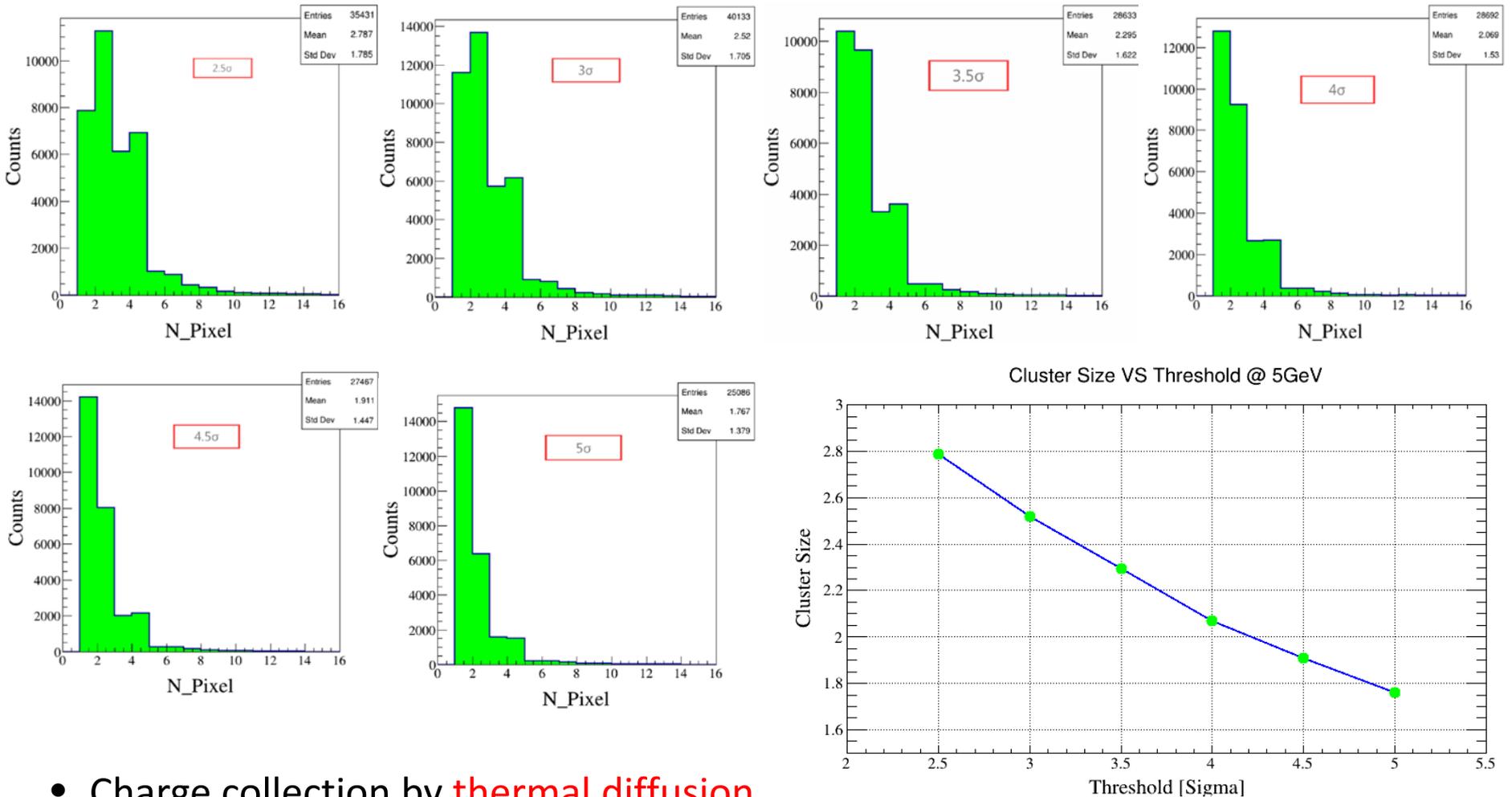


Analysis Software Framework



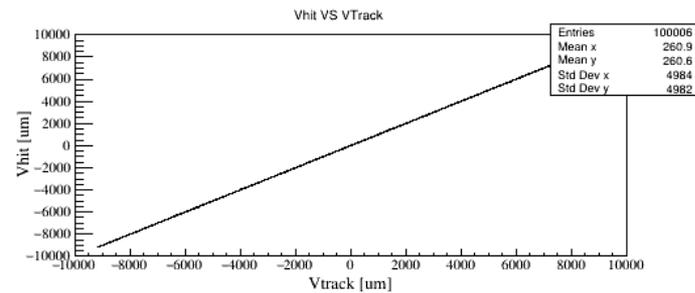
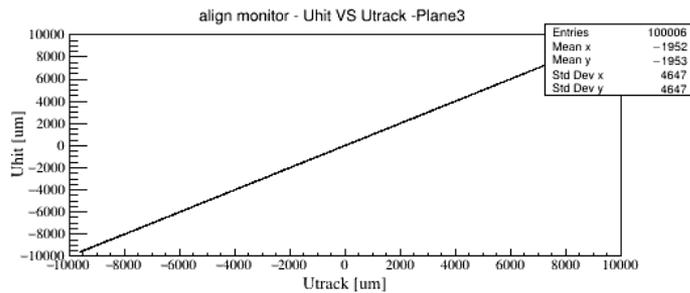
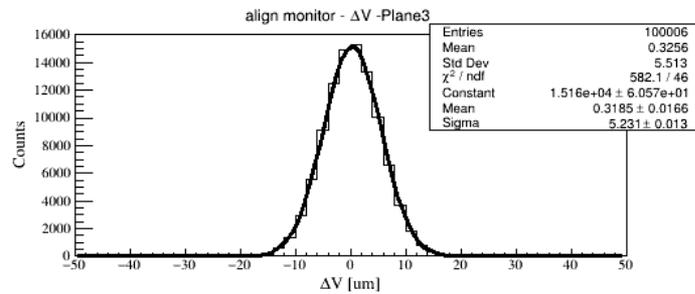
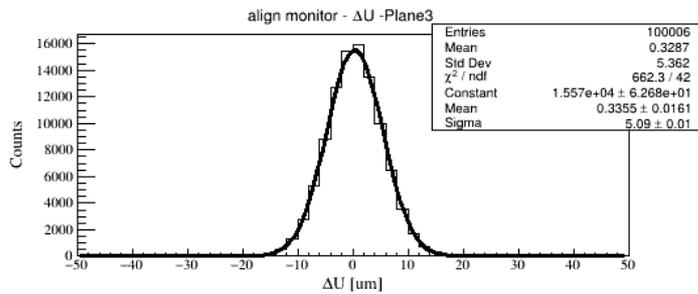
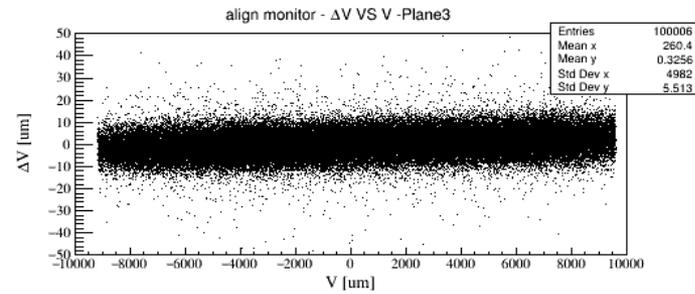
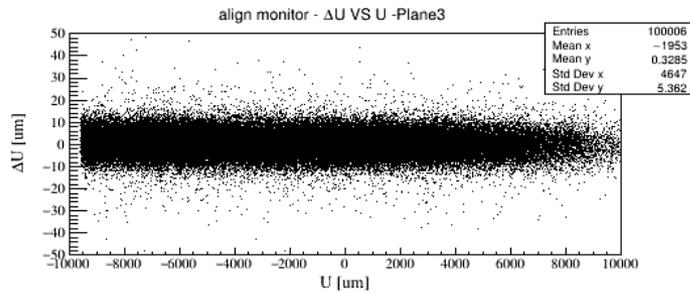
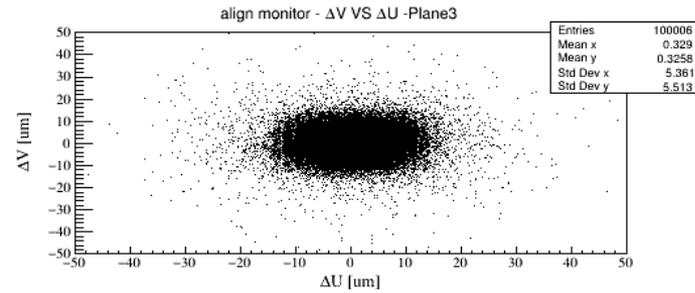
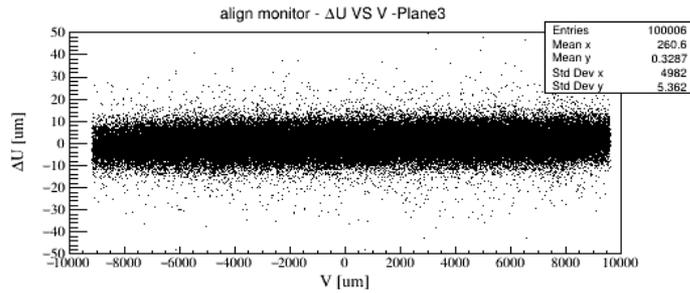
- Hit reconstruction : cluster size, digital signal, no seed
- Alignment: high precision
- Tracking:

Cluster Size Analysis



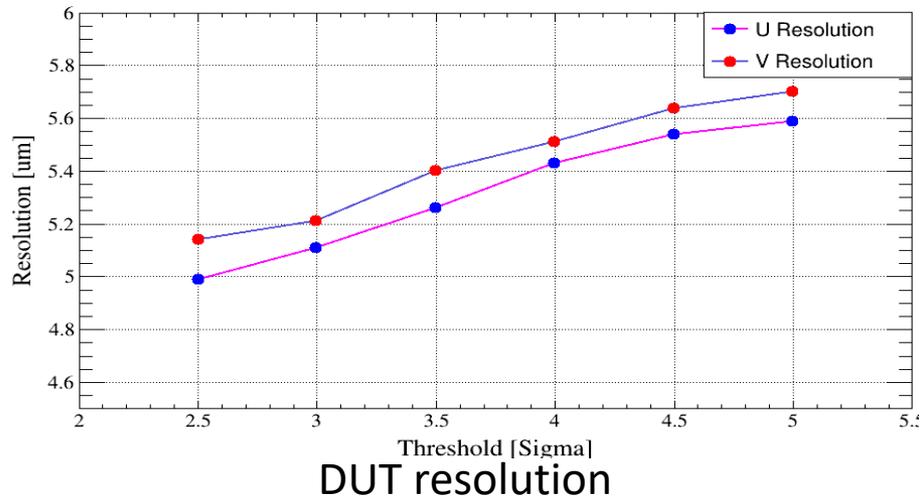
- Charge collection by **thermal diffusion**
- **Charges sharing: one hit can lead to several fired pixels, be benefit to spatial resolution**
- Reconstruction algorithm

Alignment Results

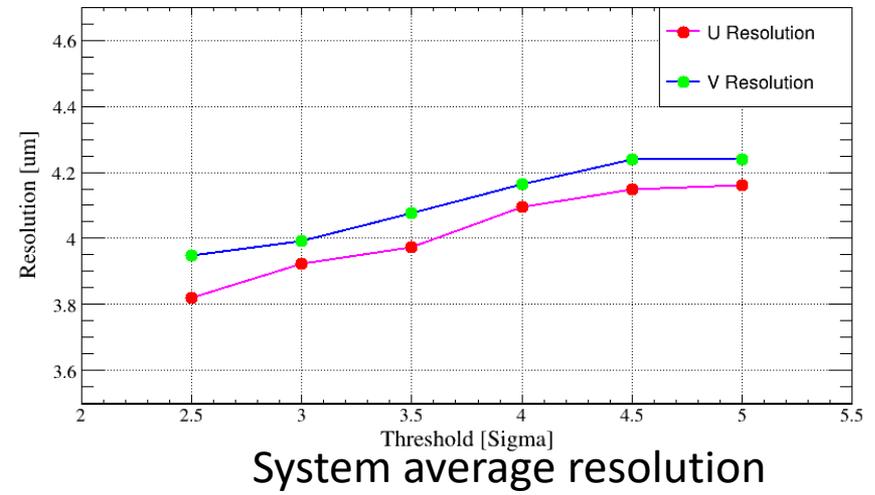


Spatial Resolution and Efficiency

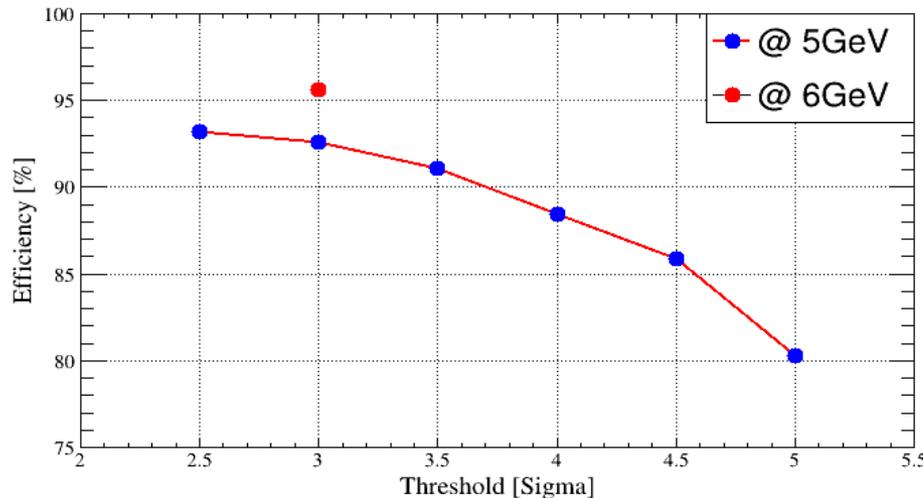
Resolution VS Threshold @ 5GeV



Resolution VS Threshold @ 5GeV

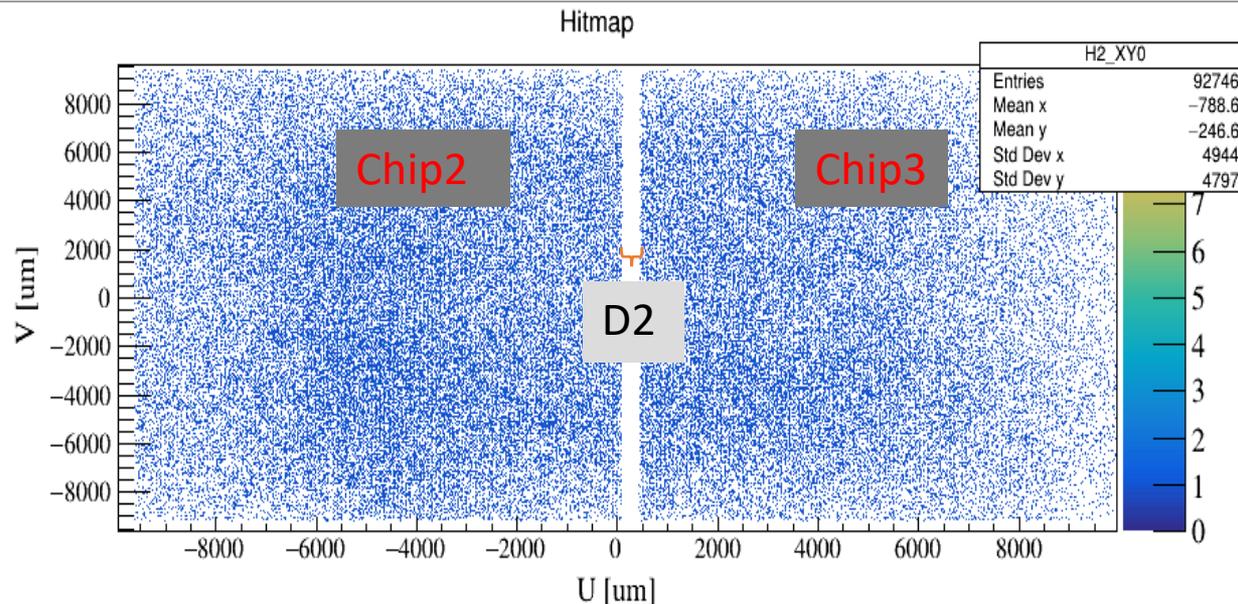
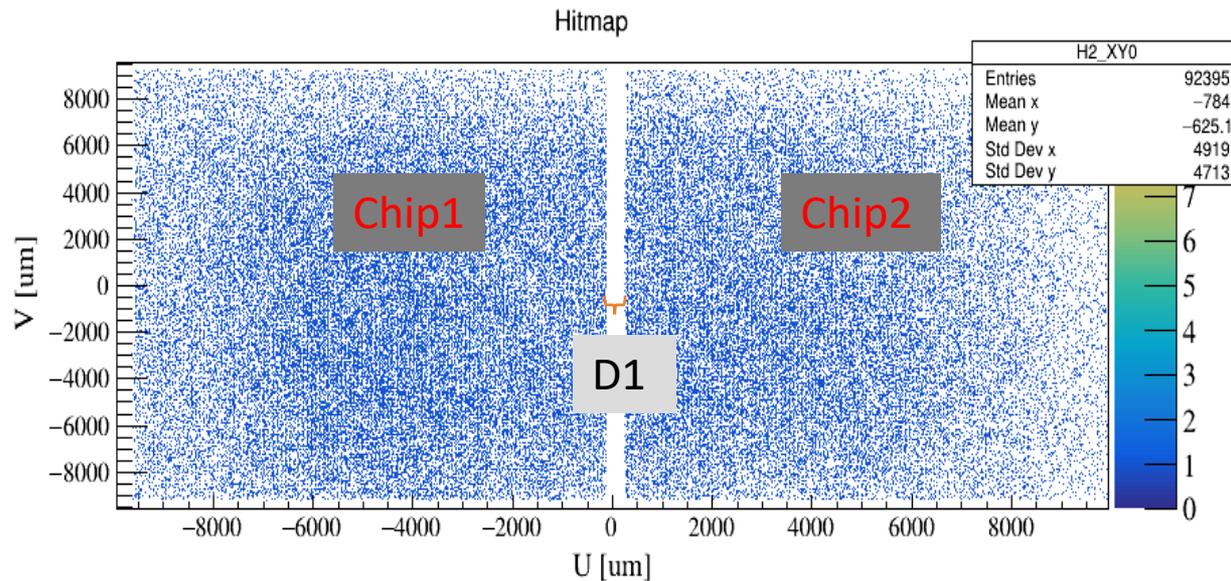


Efficiency VS Threshold



- The efficiency of MIMOSA28 was near 100%.
- The loss of ~4% of the efficiency in this test is due to the readout and DAQ system
- The readout and DAQ system will be updated and tested

Gap between two chips



- $D1 \approx D2 \approx 340\mu\text{m}$
- Average gap between neighboring chips is $340\mu\text{m}$
- Take into account the row sequencer on the chip, chip location accuracy is better than $10\mu\text{m}$

Multiple Scattering

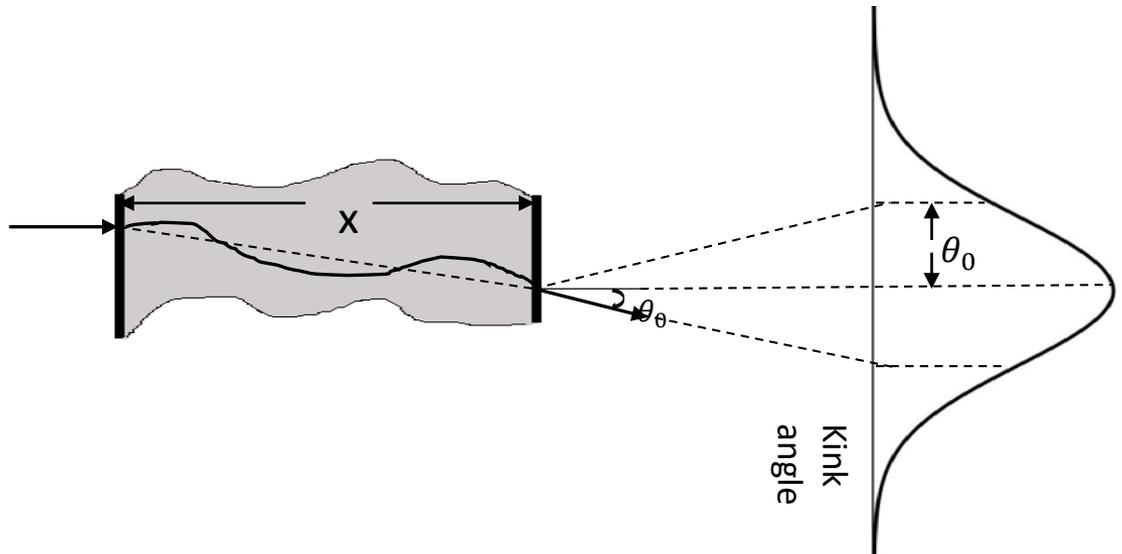
- High-energy particles undergo **multiple coulomb scattering** when passing through the material;
- Kink angle depends on **material budget (x/X_0)**;
- The **width of the gaussian-like center** is well predicted by the Highland formula;
- Highland formula: $\theta_0 = \frac{13.6 \text{ MeV}}{\beta c p} Z \sqrt{\frac{x}{X_0}} \left(1 + 0.038 \ln \left(\frac{x}{X_0} \right) \right)$

θ_0 = RMS of scattering angle

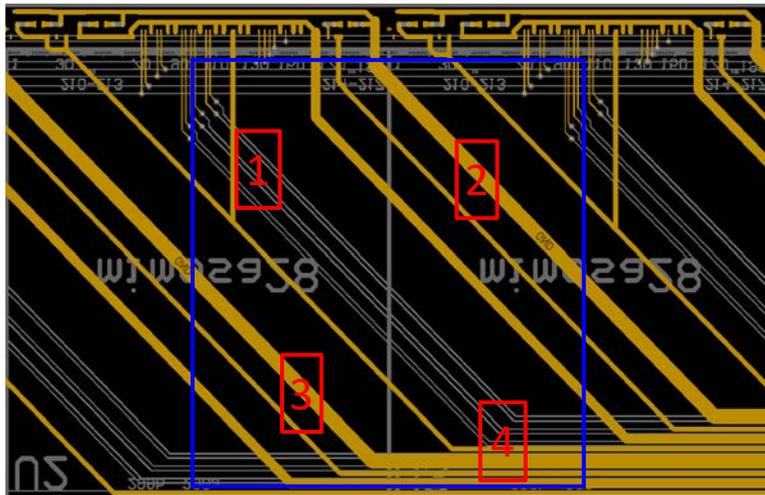
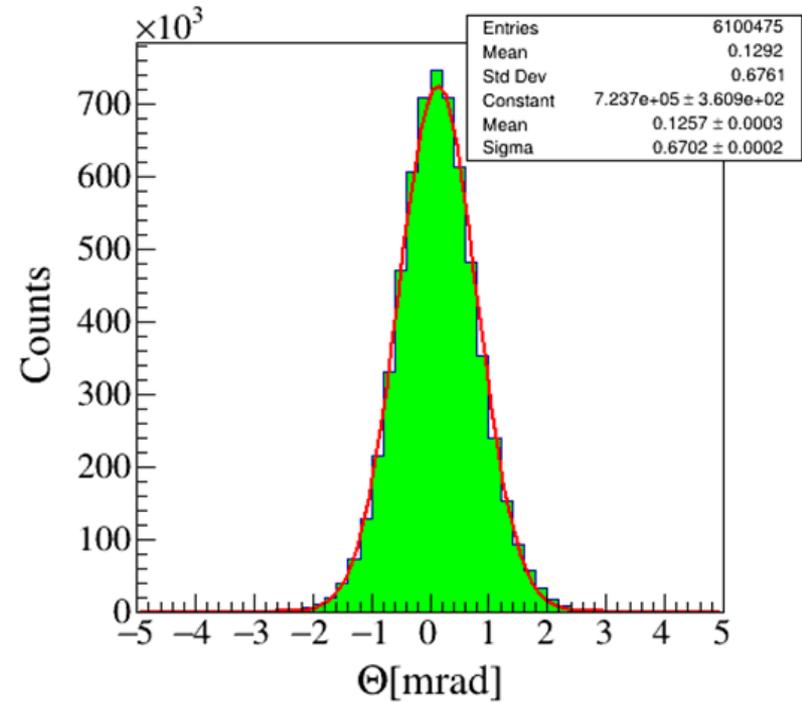
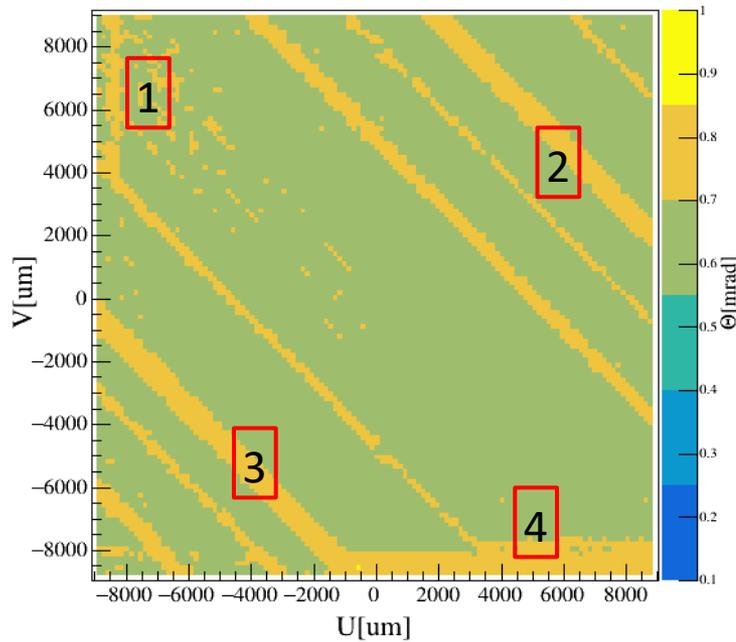
z = charge of incident particle

x = material thickness

X_0 = radiation length



Material budget



$$\theta_0 = \frac{13.6 \text{ MeV}}{\beta c p} Z \sqrt{\frac{x}{X_0}} \left(1 + 0.038 \ln \left(\frac{x}{X_0} \right) \right) \left. \vphantom{\theta_0} \right\} \frac{x}{X_0} = 0.39\%$$

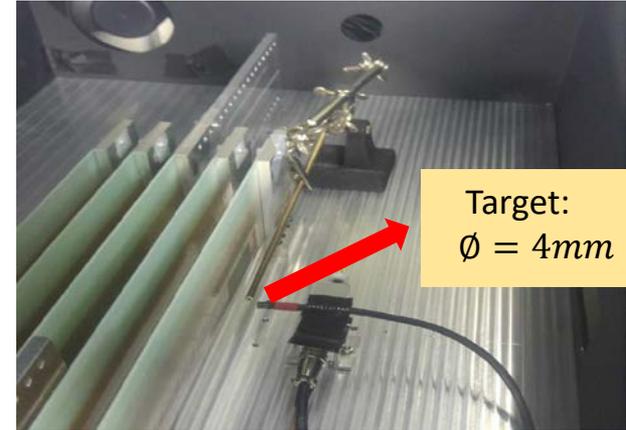
$$\theta_0 = 0.0006702 \text{ rad}$$

$$P = 1 \text{ GeV}$$

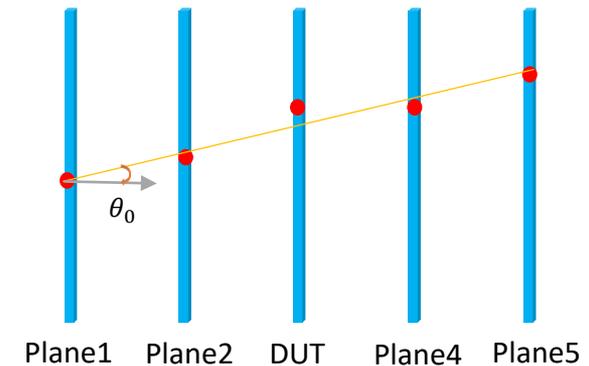
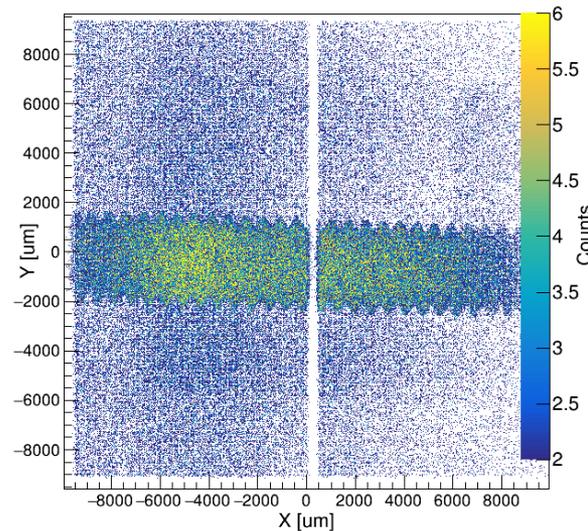
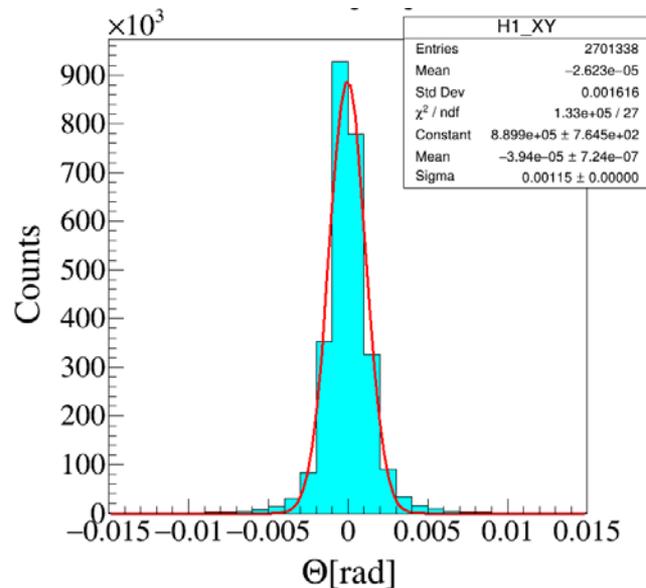
- Be consistent with the calculation result

Target Test

- Goal :Getting the target image according to multiple scattering.
 - ◆ Target in front of plane 1.
 - ◆ Target1: A copper screw ($\phi=4mm$).
 - ◆ Target: An Aluminum plate (thickness =1mm)



Target:
 $\phi = 4mm$



For the copper screw target , $\frac{x}{X_0} \Big|_{\text{theoretical}} = 21.97\% X_0$

$\theta_0 = 0.00115 \text{ rad}$, $P = 5\text{GeV}$ $\longrightarrow \frac{x}{X_0} = 20.259\%$

Outline

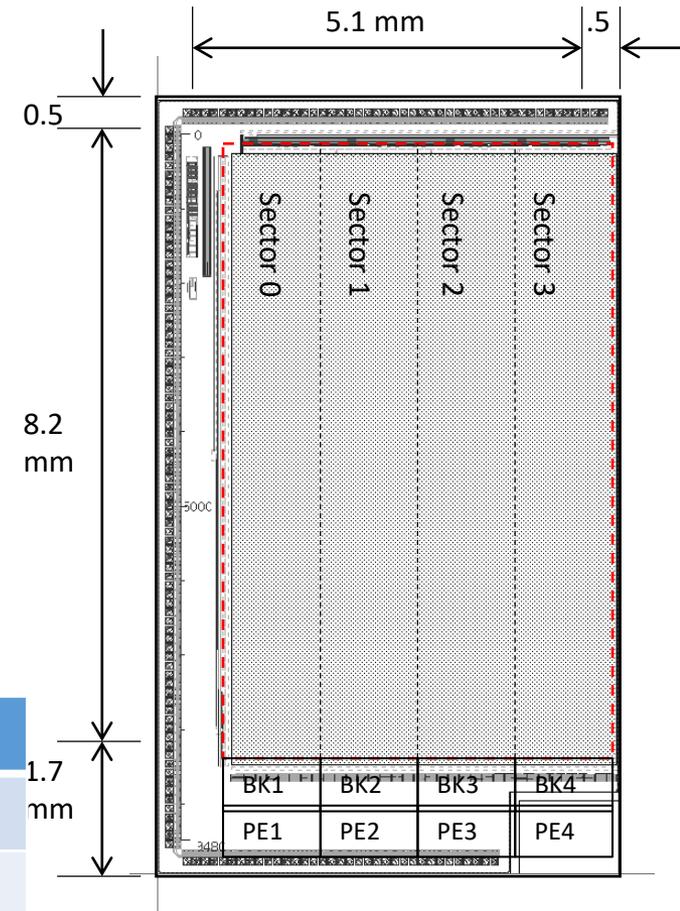
- Part of research activities in ECOPICS (Electron collider oriented pixelated CMOS sensor development)
- A CMOS pixel sensor (CPS) detector prototype study
- **CMOS pixel sensor design and planed MPW run with IPHC**

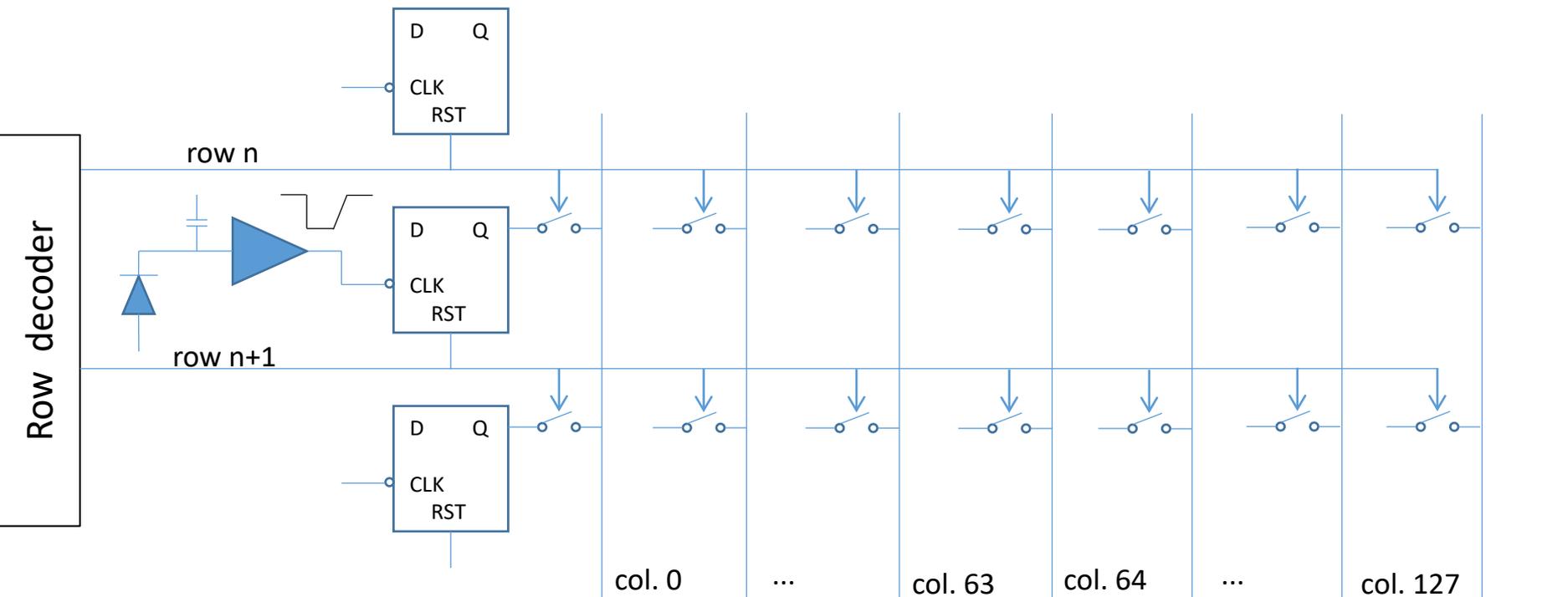
CMOS Pixel Sensor design variants

- Designed in TJ 0.18 μm CIS technology
 - The 3rd common submission with IPHC
- Diode, minimum size
- Front-end, 2 versions
 - FE_V0, FE_V1 (20nA, 60nA)
- Pixel digital, 3 versions
 - DGT_V0, DGT_V1, DGT_V2
- Pixel area
 - $16 \times 26 \mu\text{m}^2$
 - $16 \times 23.1 \mu\text{m}^2$

Four Pixel design variants

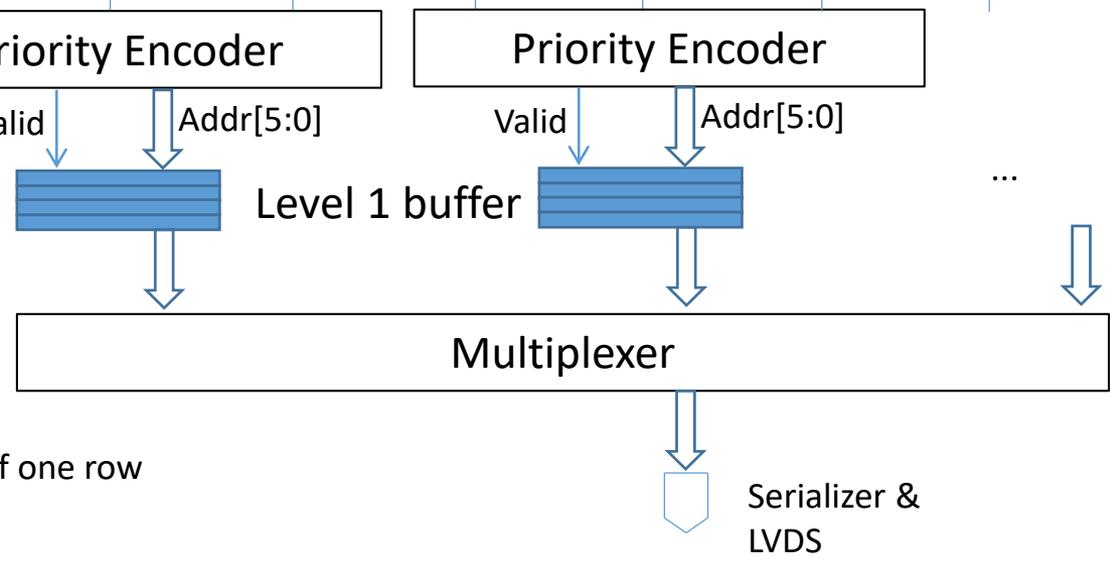
Sector	Diode	Front-end	Pixel digital	Pixel layout
0	$2 + 2 \mu\text{m}$	FE_V0	DGT_V0	$16 \times 26 \mu\text{m}^2$
1	$2 + 2 \mu\text{m}$	FE_V0	DGT_V1	$16 \times 26 \mu\text{m}^2$
2	$2 + 2 \mu\text{m}$	FE_V0	DGT_V2	$16 \times 23.11 \mu\text{m}^2$
3	$2 + 2 \mu\text{m}$	FE_V1	DGT_V0	$16 \times 26 \mu\text{m}^2$





Readout scheme

- D flip-flop to register a HIT
- Shared column lines
- End of column Priority Encoder
 - **Zero suppression**
 - 64 columns processed during readout of one row
- Multiplexer controlled by FPGA
 - Flexible readout control



Summary

- A detector prototype system was set up and tested at T24 beam line in DESY
- Good performance have been obtained: spatial resolution: $5\mu\text{m}$, efficiency : 96%, high location accuracy of the chips: $10\mu\text{m}$, low material budget: $0.39\% X_0$
- CMOS Pixel Sensor design and planed MPW run with IPHC

Thanks for your attention !